

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Jae-Geol Cho et al.

DOCKET NO.: 5000-1-501

SERIAL NO.:

10/735,192

EXAMINER:

John A. McPherson

FILED:

December 12, 2003

ART UNIT

1795

FOR:

METHOD OF FABRICATING MICRO-LENS AND METHOD OF

FABRICATING OPTICAL MODULE USING THE METHOD

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Mail Stop RCE, Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on February 19, 2008.

Steve Cha, Reg. No. 44,069 (Name of Registered Rep.)

(Signature and Date)



WITHDRAWAL FROM ISSUE

Mail Stop RCE Commissioner For Patents P. O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Applicants request withdrawal of the above-identified Patent Application from Issuance, to permit consideration of an Information Disclosure Statement Under §1.97 containing a reference cited in a Japanese Search Report dated December 11, 2007. The Issue Fee for this case is due February 19, 2008.

Favorable action on this Request for Extension of Time is courteously solicited.

Respectfully submitted

Steve Cha

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